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MAIL STOP PCT  
PATENT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application No.: 10/594,635  
PCT Appl. No.: PCT/JP2005/005766  
Applicant: Yoshiharu OHTA et al.  
Filing Date: September 28, 2006  
Group Art Unit: Unknown  
Title: SEMICONDUCTOR POLISHING COMPOSITION  
Docket No.: 2691-000050/US

REQUEST FOR RECORDATION OF  
INTERNATIONAL PRELIMINARY EXAMINATION REPORT

**MAIL STOP PCT**

December 26, 2006

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

Applicant attaches hereto an English translation of the International Preliminary Examination Report which has been issued in connection with the above-identified application. Please make this document part of the prosecution history of the present application.

Respectfully submitted,

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By:   
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Attachment: International Preliminary Examination Report